Doc code :IDS

Doc description: Information Disclosure Statement (IDS) Filed

PTO/SB/08a (08-08)

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			Tanas namba,		
Application Number		10576169			
Filing Date		2006-04-19			
First Named Inventor	Shinya Ogasawara				
Art Unit		2627			
Examiner Name	Tianjie Chen				
Attorney Docket Numb	er	9694-000043/US/NP			

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	1	1321935	EP			2003-06-25	.Clarion Co., Ltd.			×

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į First Named inventor į Shinya Ogasawara							
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